PROCEEDINGS OF SPIE

Reflection, Scattering, and Diffraction from Surfaces V

Leonard M. Hanssen Editor

28–29 August 2016 San Diego, California, United States

Sponsored and Published by SPIE

Volume 9961

Proceedings of SPIE 0277-786X, V. 9961

SPIE is an international society advancing an interdisciplinary approach to the science and application of light.

Reflection, Scattering, and Diffraction from Surfaces V, edited by Leonard M. Hanssen, Proc. of SPIE Vol. 9961, 996101 · © 2016 SPIE · CCC code: 0277-786X/16/\$18 · doi: 10.1117/12.2256406

Proc. of SPIE Vol. 9961 996101-1

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ISSN: 0277-786X ISSN: 1996-756X (electronic) ISBN: 9781510603134 ISBN: 9781510603141 (electronic)

Published by **SPIE** P.O. Box 10, Bellingham, Washington 98227-0010 USA Telephone +1 360 676 3290 (Pacific Time) · Fax +1 360 647 1445 SPIE.org

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